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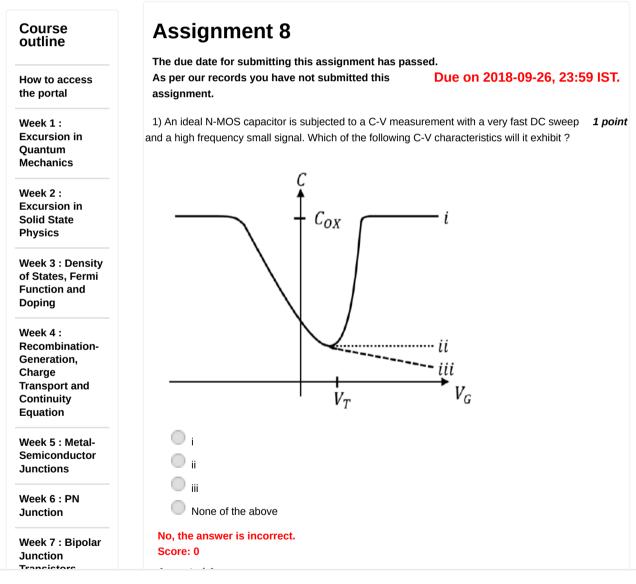
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reviewer3@nptel.iitm.ac.in ▼

Courses » Semiconductor Devices and Circuits

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Unit 9 - Week 8 : Metal Oxide Semiconductor Capacitor (MOSCAP) and CV Characteristics



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Characteristics	522 nm	
Metal Oxide	41 nm	
Semiconductor		
Capacitor	872 nm	
(MOSCAP)	311 nm	
MOSCAP - Continued	No, the answer is incorrect.	
MOSCAP: C-V	Score: 0	
Characteristics	Accepted Answers:	
MOSCAP: C-V	41 nm	
Characteristics		
- Continued		oint
Out-	semiconductor interface. Which mode is the MOS capacitor operating?	
Quiz : Assignment 8		
	strong inversion	
Assignment 8:	weak inversion	
Solution	depletion	
Week 9:		
MOSFET: I	accumulation	
	No, the answer is incorrect.	
Week 10: MOSFET: II	Score: 0	
WOSFET: II	Accepted Answers:	
Week 11:	accumulation	
Circuits		
	, , , , , , , , , , , , , , , , , , , ,	oint
Week 12: Thin	to $N_A=1X10^{16}/cc$. The oxide is silicon dioxide with a thickness of 55 nm. The area of the dev	
Film Transistors	is $2X10^{-3}cm^2$. Assume thermal voltage is 25.9 mV and $n_i=1.5X10^{10}/cc$. Calculate the value $n_i=1.5X10^{10}/cc$	ılue
(TFTs), Tutorial Sessions	of total oxide capacitance of the device in picofarads.	
	0	
	126 pF	
	62.8 pF	
	628 pF	
	12.6 pF	
	No, the answer is incorrect.	
	Score: 0	
	Accepted Answers:	
	126 pF	
	5) For the MOS-capacitor given in question (4), calculate the value of maximum depletion 1 p	oint
	width x_d .	
	27 μ m	
	9 μ m	
	3 μ m	
	0.3 μ m	
	No, the answer is incorrect.	
	Score: 0	
	Accepted Answers:	
	0.3 µm	
	6) For the MOS-capacitor given in question (4), calculate the value of effective	oint

capacitance C_{eff} (unit-area capacitance) corresponding to when maximum depletion width is achieved.
$7.24X10^{-10}F/cm^2$
$2.23X10^{-8}F/cm^2$
$6.56X10^{-9}F/cm^2$
None of the above
No, the answer is incorrect. Score: 0
Accepted Answers: $2.23X10^{-8}F/cm^2$
7) For a MOS-capacitor biased in accumulation mode, the effective capacitance is: 1 point
$\frac{C_{ox}}{2}$
$C_{ox} + C_{dep}$
$rac{C_{ox}*C_{dep}}{C_{ox}+C_{dep}}$
$\overline{C_{ox}\!+\!C_{dep}}$
C_{ox}
No, the answer is incorrect.
Score: 0
Accepted Answers:
C_{ox}
8) Consider the following statements: 1 point
For a MOS capacitor with gate voltage equal to the threshold voltage,
i. The surface potential is equal to twice the value of ϕ_F
ii. There is no band-bending in the semiconductor iii. The inversion charge concentration at the interface matches the majority carrier concentration in the
bulk iv. The surface potential is equal to ϕ_F
Which of the above statements are false?
o iv only
iii and iv
ii and iv
i only
No, the answer is incorrect. Score: 0
Accepted Answers: ii and iv
9) For a MOS-capacitor under strong inversion, the surface charge density: 1 point

Accepted Answers: - 0.32 V	
No, the answer is incorrect. Score: 0	
- 0.13 V	
- 0.77 V	
0.8 V	
- 0.32 V	
10)Consider a MOS capacitor with p-type silicon substrate at T=300K doped to $N_A=1X10^{14}/cc$. The oxide is silicon dioxide with a thickness of 50nm Assume $n_i=1.5X10^{10}/cc$ and thermal voltage is 25.9mV. Calculate the MOS capacitor.	i. Let $\phi_{MS}=-0.83V$.
Accepted Answers: increases exponentially as a function of surface potential	
No, the answer is incorrect. Score: 0	
does not change with surface potential	
increases linearly as a function of surface potential	
increases exponentially as a function of surface potential	
decreases exponentially as a function of surface potential	